

Notice of References Cited			Application No.	Applicant(s)		
			08/994,038	Shunpei Yamazaki, Satoshi Teramoto		
Examiner William David Coleman			Group Art Unit 2814	Page 1 of 1		
U.S. PATENT DOCUMENTS						
	DOCUMENT NO.	DATE	NAME		CLASS	SUBCLASS
A	5,824,235	10/20/98	Shunpei Yamazaki et al.		216	23
B	5,569,936	10/29/96	Hongyong Zhang et al.		257	57
C						
D						
E						
F						
G						
H						
I						
J						
K						
L						
M						
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
N						
O						
P						
Q						
R						
S						
T						
NON-PATENT DOCUMENTS						
	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					DATE
U	Schoenfeld et al., Crystallization of amorphous silicon by NiSi sbu 2 precipitates, Thin Solid Films, pp236-240					6/95
V						
W						
X						